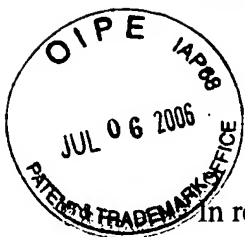


IFW

00862.023171

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAKASHI ARAI

Application No.: 10/634,860

Filed: August 6, 2003

For: METHOD OF STORING  
MATERIAL INTO WHICH GAS  
SATURATES

)  
: Examiner: F. Lawrence  
)  
: Group Art Unit: 1724  
)  
:  
)  
:  
)  
:  
) July 5, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated April 21, 2006, please amend the  
above-captioned application as follows and consider the following remarks.